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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: KORZENSKI, Michael B., et al.

Application No.: 10/807,858

Date Filed: March 24, 2004

Title: COMPOSITION USEFUL FOR
REMOVAL OF BOTTOM
ANTI-REFLECTION
COATINGS FROM
PATTERNED ION-
IMPLANTED PHOTORESIST
WAFERS

Docket No.: 020732-110.694

Examiner: AHMED, Shamim

Art Unit: 1765

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FACSIMILE TRANSMISSION CERTIFICATE

Attn: Examiner Shamim Ahmed

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Number of Pages (including cover)

Lillian Glenn

January 9, 2007

Date

AMENDMENT RESPONDING TO OCTOBER 24, 2006 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/807,858

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Sir:

This responds to the October 24, 2006 Office Action in the above-identified application.